

PATENT

Attorney Docket No. MTI-31532

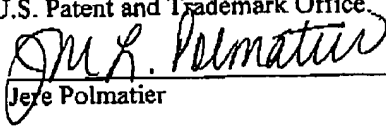
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Weimer, Ronald A.
Serial No.: 09/941,827
Filing Date: August 29, 2001
For: Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices
Examiner: PHAM, Thanhha S.
Group Art Unit: 2813
Confirmation No.: 7551

CERTIFICATION OF SUBMISSION

I hereby certify that, on the date shown below, this correspondence is being transmitted via facsimile no. 571-273-1696 addressed to Examiner PHAM at the U.S. Patent and Trademark Office.

Date: July 19, 2006


Jere Polmatier

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This response replies to Examiner Pham's telephone call of July 18, 2006. Applicant has accepted the Examiner's proposed amendments and hereby requests consideration of the pending claims in the above-identified patent application based on the remarks herein.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 32 of this paper.